

10/518704

PATENT

930055-2031

DT01 Rec'd PCT/PTC

17 DEC 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Tetsuo YAMADA, Kosuke NISHIMURA, Keigo NAGAO  
Serial No. : Not Yet Assigned  
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN  
FILM PIEZOELECTRIC DEVICE, AND  
MANUFACTURING METHOD THEREOF  
Filed :  
Int'l Appln. No. : PCT/JP2003/007857  
Int'l Filing Date : 20 June 2003 (20.06.2003)  
Priority Date : 20 June 2002 (20.06.2002)  
Examiner : Not Yet Assigned  
Art Unit : Not Yet Assigned

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Date of Deposit: December 17, 2004

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**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

Preliminary to the examination of the above referenced patent application,

Applicants respectfully request that the application be amended as follows: